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	1.	08/21/2003	2003/0156842	Morimoto et al.					
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Complete if Known				
Application Number	10/728,238			
Filing Date	December 3, 2003			
First Named Inventor	Hironori TANIGUCHI			
Art Unit	2633			
Examiner Name	J. Chan			
Attorney Docket Number	245402007900			

U.S. PATENT DOCUMENTS							
Examiner initials*	Cite No.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		

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DSK	1.	CN-1081413-C	03-20-2002	IBM Corporation				
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Signature	/David S. Kim/	Considered	03/23/2000
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